



Attorney Docket No. 0756-7259

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA et al.

Serial No. 10/787,120

Filed: February 27, 2004

For: LASER IRRADIATION METHOD,

LASER IRRADIATION APPARATUS,

AND METHOD FOR

MANUFACTURING

SEMICONDUCTOR DEVICE

) Group Art Unit: 2818

) Examiner: Chuong A. Luu

) CERTIFICATE OF MAILING

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Honorable Commissioner of Patents

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Dear Sir:

In response to the *Notice of Allowance and Fee(s) Due* dated October 2, 2007,  
enclosed is the Publication Fee in the amount of \$300.00.

Respectfully submitted,

Eric J. Robinson  
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